



Corres. and Mail  
**BOX AF**

Response Under 37 CFR § 1.116  
Expedited Procedure - Group 1755

03500.017562.

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

MAKOTO KUBOTA, ET AL.

Application No.: 10/665,429

Filed: September 22, 2003

For: COMPOSITION FOR  
FORMING PIEZOELECTRIC  
FILM, MANUFACTURING  
METHOD OF  
PIEZOELECTRIC FILM,  
PIEZOELECTRIC ELEMENT  
AND INK JET RECORDING  
HEAD

Examiner: C. Koslow

Group Art Unit: 1755

June 29, 2005

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION**

Sir:

In response to the final Office Action dated March 29, 2005, please amend  
the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope addressed  
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-  
1450 on

June 29, 2005  
(Date of Deposit)

Diamond E. Vadnais, Reg. No. 52,310  
(Name of Attorney for Applicant)

  
Signature

June 29, 2005  
Date of Signature

BEST AVAILABLE COPY

pls  
enter

PER  
RCE

8/1/05

00-108-102  
-6-  
7/15/05